

**PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80568

Tsutomu SHOKI

Appln. No.: 10/802,886

Group Art Unit: 1756

Confirmation No.: 5197

Examiner: Stephen D. ROSASCO

Filed: March 18, 2004

For: METHOD OF PRODUCING A REFLECTIVE MASK AND METHOD OF
PRODUCING A SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three month(s), extending the time for responding to the Office Action of October 13, 2006 to April 13, 2007.

The statutory fee of \$1020.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

/Alan J. Kasper/

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Date: April 13, 2007